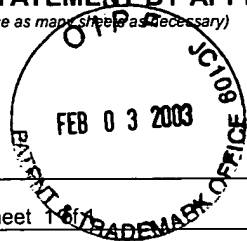


Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)



Sheet 1 of 1

Complete if Known

Application Number 09/945397

Filing Date August 30, 2001

First Named Inventor Sandhu, Gurtej

Group Art Unit 2822

Examiner Name Unknown

Attorney Docket No: 303.541US2

**US PATENT DOCUMENTS**

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate
MT	US-4,093,503	06/06/1978	Harris, E, et al	156	628	03/07/1977
	US-4,571,817	02/25/1986	Birritella, M, et al	29	576 B	03/15/1985
	US-4,847,214	07/11/1989	Robb, F., et al	437	67	04/18/1988
	US-5,358,908	10/25/1994	Reinberg, A. R., et al	437	228	02/14/1992
	US-5,422,294	06/06/1995	Noble, Jr., W	437	52	05/03/1996
	US-5,484,740	01/16/1996	Cho, J	437	40	06/06/1994
	US-5,963,804	10/05/1999	Figura, T, et al	438	255	03/14/1997
	US-6,025,246	02/15/2000	Kim, Tae-sung	438	396	06/07/1996
MT	US-6,177,340	01/23/2001	Yoo, et al	438	637	02/18/1999

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T <sup>2</sup>
--------------------	---------------------	------------------	---	-------	----------	----------------

**OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
MT		KUHN, G., et al. , "Thin Silicon Film on Insulating Substrate", <u>Journal of the Electrochemical Society</u> , 120(11), (1973), pp. 1563-1566	
MT		SCHNAKENBERG, U., et al. , "TMAHW Etchants for Silicon Micromachining", <u>Transducers - International Conference on Solid-State Sensors and Actuators - Digest of Technical Papers</u> , (1991), pp. 815-818	

EXAMINER

Michael Trinch

DATE CONSIDERED

6/14/03 -